



MS ISO/IEC 17025

# Certificate of Accreditation

**No: SAMM 549**

(Issue 3, 21 February 2013 replacement  
of SAMM 549 dated 27 August 2012)

Valid until: 10 February 2015

This is to certify that

**CLMO TECHNOLOGY (PENANG) SDN. BHD.**  
**BAYAN LEPAS, PENANG**  
**MALAYSIA**  
(FIELD OF CALIBRATION: TEMPERATURE)  
(FIELD OF TESTING: MECHANICAL)

has been granted accreditation in respect of the scope of accreditation described in the SCHEDULE attached, subject to the terms and conditions governing the *Skim Akreditasi Makmal Malaysia (SAMM)*, the Laboratory Accreditation Scheme of Malaysia.

*"This laboratory is accredited in accordance with the recognised International Standard ISO/IEC 17025:2005. This accreditation demonstrates technical competence for a defined scope and the operation of a laboratory quality management system (refer joint ISO-ILAC-IAF Communiqué dated January 2009)".*

Issuance of this certificate is governed by Section 16 Subsection (2) and (3) of Standards of Malaysia Act 1996, (Act 549).



**(FADILAH BAHARIN)**  
Director General  
Department of Standards Malaysia

Date of issue: 21 February 2013



**NO: SAMM 549**

(Issue 4, 21 February 2013 replacement of SAMM 549 dated 21 November 2012)

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**LABORATORY LOCATION:**  
(PERMANENT LABORATORY)

**CLMO TECHNOLOGY (PENANG) SDN. BHD.**  
**NO. 6, LINTANG BAYAN LEPAS 2**  
**TAMAN PERINDUSTRIAN BAYAN LEPAS FASA 4**  
**11900 BAYAN LEPAS**  
**PENANG, MALAYSIA**

This laboratory accredited under *Skim Akreditasi Makmal Malaysia* (SAMM) meets the requirements of MS ISO/IEC 17025:2005 'General requirements for competence of testing and calibration laboratories'. This Malaysian Standards is identical with ISO/IEC 17025:2005 published by the International Organization for Standardization (ISO).

\* The expanded uncertainties are based on an estimated confidence probability of not less than 95% and have a coverage factor of  $k=2$  unless stated otherwise.

**FIELD OF CALIBRATION:** TEMPERATURE

**SITE CALIBRATION:** CATEGORY III

**SCOPE OF ACCREDITATION:**

Instrument Calibrated/ Measurement Parameter	Range	Calibration and Measurement Capability Expressed as an Uncertainty ( $\pm$ )*	Remarks
Temperature Enclosure	30 °C to 300 °C	0.8 °C	Temperature fluctuation range based on JTM K-05:2000 clause 6.3
	-80 °C to 200 °C	0.5 °C	Temperature fluctuation range based on JTM K-01:1998 clause 6.3
Temperature & Humidity Chamber	-80 °C to 150 °C (without humidity)	0.5 °C	Temperature fluctuation based on JTM K-01:1998 clause 6.3
	10 °C to 85 °C 5 %RH to 98 %RH	0.5 °C 2.5 %RH	Temperature and humidity fluctuation based on JTM K-01:1998 clause 6.3
Temperature & Humidity Room	-40 °C to 80 °C (without humidity)	0.5 °C	Temperature fluctuation only based on JTM K-03:2001 clause 6.3
	10 °C to 80 °C 5 %RH to 98 %RH	0.5 °C 2.5 %RH	Temperature and humidity fluctuation only based on JTM K-03:2001 clause 6.3

**Signatories:**

1. Teng Thiam Wan
2. Pung Chee Hon



**NO: SMM 549**

(Issue 4, 21 February 2013 replacement of SMM 549 dated 21 November 2012)

**FIELD OF TESTING: MECHANICAL (ENVIRONMENTAL TESTING)**

**SCOPE OF ACCREDITATION:**

Materials/ Products Tested	Type of Test/ Properties Measured/ Range of Measurement	Standard Test Method/ Equipment/Techniques
Semiconductor, printed circuit board assembly, finished electrical and electronic product	Change of temperature Max temperature = 150 °C Min temperature = -65 °C	IEC 60068-2-14:2009 (Test Na and Test Nb)
	Damp heat cyclic 10 °C to 85 °C 20 %RH to 98 %RH	IEC 60068-2-30:2008
	Dry heat 30 °C to 200 °C	MS IEC 60068-2-2:2007 (Test Bb)
	Damp heat, steady state 10 °C to 85 °C 20 %RH to 98 %RH	MS IEC 60068-2-78:2008

**Signatories:**

1. **Teng Thiam Wan**
2. **Pung Chee Hon**

